



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
www.uspto.gov



CONFIRMATION NO. 8920

Bib Data Sheet

SERIAL NUMBER 10/800,112	FILING OR 371(c) DATE 03/12/2004 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 008245/DSM/BCVD
-----------------------------	--	--------------	------------------------	---

APPLICANTS

Yuxiang May Wang, Palo Alto, CA;
 David R. Bitrich, Madison, WI;
 Christopher Dennis Bencher, San Jose, CA;
 Heraldo L. Botelho, Palo Alto, CA;
 Sudha S. R. Rathi, San Jose, CA;
 Michael Chiu Kwan, Sunnyvale, CA;

**** CONTINUING DATA *********** FOREIGN APPLICATIONS *********IF REQUIRED, FOREIGN FILING LICENSE GRANTED**

** 07/31/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	CA	1	22	3
Verified and Acknowledged	<i>Juanita</i> <i>Mest</i> Examiner's Signature Initials				

ADDRESS

44257

TITLE

Method of depositing an amorphous carbon film for metal etch hardmask application

FILING FEE RECEIVED 936	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
----------------------------	---	---